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CENTRAL FAX CENTER Attorney Docket No.: 0150140

MAR 03 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Rha, et al.

Art Unit: 2823

Serial No.: 10/758,494

Examiner: Coleman, William D.

Filed: January 15, 2004

For: Circuit for Detecting Arcing in an
Etch Tool During Wafer Processing

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the *Final Office Action* dated December 5, 2005 in
the above-referenced patent application. Please enter and consider the following
remarks.